Attorney Docket: 081468-0307331 Client Reference: P-1774.000-US



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:

Confirmation Number: 4441

HELMAR VAN SANTEN et al.

Group Art Unit: 2851

Application No.: 10/743,271

Filed: December 23, 2003

Examiner: NGUYEN, HUNG

Title: LITHOGRAPHIC APPARATUS AND DEVICE MANUFACTURING METHOD

## COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE

Mail Stop Issue Fee Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

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In the Office Action dated November 20, 2006, the Examiner has set forth "Reasons for Allowance." Applicants respectfully traverse these Reasons. Specifically, it is submitted that the subject matter of the allowed claims are patentable for their respective claimed elements and limitations as a whole. That is, the patentability of the claims rests on the combination of recited elements and limitations. As such, Applicants submit that no one element or limitation in particular should be deemed to impart or be required for patentability of the claims. Furthermore, Applicants submit that the dependent claims are allowable not only for their dependence on the allowed independent claims, but also for the additional subject matter recited in each of those dependent claims.

Respectfully submitted,

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